


<b>Search Notes</b>  	<b>Application/Control No.</b>  10541200	<b>Applicant(s)/Patent Under Reexamination</b>  NAWATA, SATORU
	<b>Examiner</b>  Haugland, Scott	<b>Art Unit</b>  3654

SEARCHED			
Class	Subclass	Date	Examiner
226	4,25,26,44,48,100,118.2,118.3		
242	147M,148,418,418.1,472.9,534,535,535.3,538,538.2,550,552,563		
139	336,353,354,368,370.1,372		
156	361,378		
200	61.18		
192	125R,125A,126,127		
28	187		
57	81		
66	158,160,161,163		
72	3,4		
396	615,623,624,646	10/2/07	/SJH/
updated search		7/8/08	/SJH/

SEARCH NOTES		
Search Notes	Date	Examiner

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner